Customer No. 20,995

Docket No.: ASMJP.137AUS

INFORMATION DISCLOSURE STATEMENT

Applicant

Yasuyoshi Hyodo, et al.

App. No.

Unknown

Filed

Herewith

For

METHOD OF FORMING SILICON-

CONTAINING INSULATION FILM

HAVING LOW DIELECTRIC

CONSTANT AND LOW FILM STRESS

Examiner

Unknown

Group Art Unit

Unknown

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing references that are also enclosed.

This Information Disclosure Statement is being filed within three months of the filing date of this application or upon filing if this is a CPA or RCE, and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: August 20, 2003

By:

Katsuhiro Arai

Registration No. 43,315

Agent of Record

Customer No. 20,995

(949) 760-0404

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FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY, DOCKET NO. ASMJP.137AUS	APPLICATION NO. Unknown	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)			<u></u>	
		APPLICANT Yasuyoshi Hyodo, et al.		
		FILING DATE Herewith	GROUP Unknown	

U.S. PATENT DOCUMENTS							
EXAMINER DOCUMENT NUMBER DATE NAME		NAME			FILING DATE (IF APPROPRIATE)		
	1.	6,455,445	09/24/02	Nobuo Matsuki			
	2.	10/402,109		Nobuo Matsuki, et al.			03/27/03
	3.	10/412,363		Yasuyoshi Hyodo, et al.			04/11/03
	4.	10/351,669		Naoto Tsuji, et al.			01/24/03

	FOREIGN PATENT DOCUMENTS							
EXAMINER		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
INITIAL							YES	NO
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EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)			
1				

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EXAMINER	DATE CONSIDERED .
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WIT	